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	Application No.	Applicant(s)	
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Notice of Allowability	10/630,161 Examiner	STEWART, ROBERT Art Unit	E.
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	Alexander G. Ghyka	2812	
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate commu GHTS. This application is so	this application. If not included nication will be mailed in due of	l ourse. THIS
1. This communication is responsive to			
2. The allowed claim(s) is/are <u>18-28</u> .			
3. \boxtimes The drawings filed on <u>30 July 2003</u> are accepted by the Ex	aminer.	,	
 4. ☐ Acknowledgment is made of a claim for foreign priority una) ☐ All b) ☐ Some* c) ☐ None of the: 1. ☐ Certified copies of the priority documents have 2. ☐ Certified copies of the priority documents have 3. ☐ Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application	n No	on from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requ	irements
5. A SUBSTITUTE OATH OR DECLARATION must be subminformal PATENT APPLICATION (PTO-152) which give			TICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mus (a) including changes required by the Notice of Draftspers		(PTO-948) attached	
 1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date 	s Amendment / Comment or i	in the Office action of	
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in t	84(c)) should be written on the needer according to 37 CFF	e drawings in the front (not the b R 1.121(d).	ack) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT I			te the
Attachment(s) 1. ☑ Notice of References Cited (PTO-892)	5. ☐ Notice of Info	ormal Patent Application (PTO-	152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)		mmary (PTO-413),	,
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0		Mail Date Amendment/Comment	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit	8. 🛭 Examiner's S	Statement of Reasons for Allow	ance
of Biological Material	9. 🗌 Other		
		ALEXANDER GHYKA PRIMARY EXAMINER	
U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04) No	tice of Allowability	Part of Paper No	./Mail Date 0220

DETAILED ACTION

Examiner's Amendment

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Carmen B. Patti on February 20, 2004.

The application has been amended as follows:

Cancel Claim 29.

In Claim 19, line 2, delete "a first surface having",and insert – a first wafer having--.

In Claim 19, line 3, insert – of --,

between "first surface" and "the first wafer".

Allowable Subject Matter

Claims 18-28 are allowed.

The following is an examiner's statement of reasons for allowance: The closest art known to the Examiner is listed on the attached PTO 892 form. None of the

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references or combinations thereof disclose or suggest an apparatus comprising a second wafer aligned with such that the hydrolyzed first surface of the first wafer and a first surface of the second wafer are touching; a heater to elevate the first and second wafer to a fusion bonding temperature; and an electric field device for applying an electric field to the wafers to create an attractive force between the wafers, as required by the presently claimed invention. Therefore, Claims 18-28 are allowed over the cited prior art. Divisional Application, now US Patent No. 6,610,582 is merely cited to show the state of the art.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alexander G. Ghyka whose telephone number is (571) 272-1669. The examiner can normally be reached on Monday through Thursday during regular business hours.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John F Niebling can be reached on (571) 272-1679. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

AGG February 20, 2004 ALEXANDER GHYKA PRIMARY EXAMINER

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